

This project has received funding from the European Union's Horizon 2020 Research and Innovation programme under GA No 101004730.

AM applications of refractory metals for ION Source

Beneficiaries:

INFN – National Institute for Nuclear Physics (PD and LNL) CERN ISOLDE TANIOBIS GmbH

Industrial partners:

GE UPPSALA SAES GETTERS S.p.A. EOS - Electro Optical Systems, Finland Oy TRIUMF



Project Evaluation, November 16th, 2022



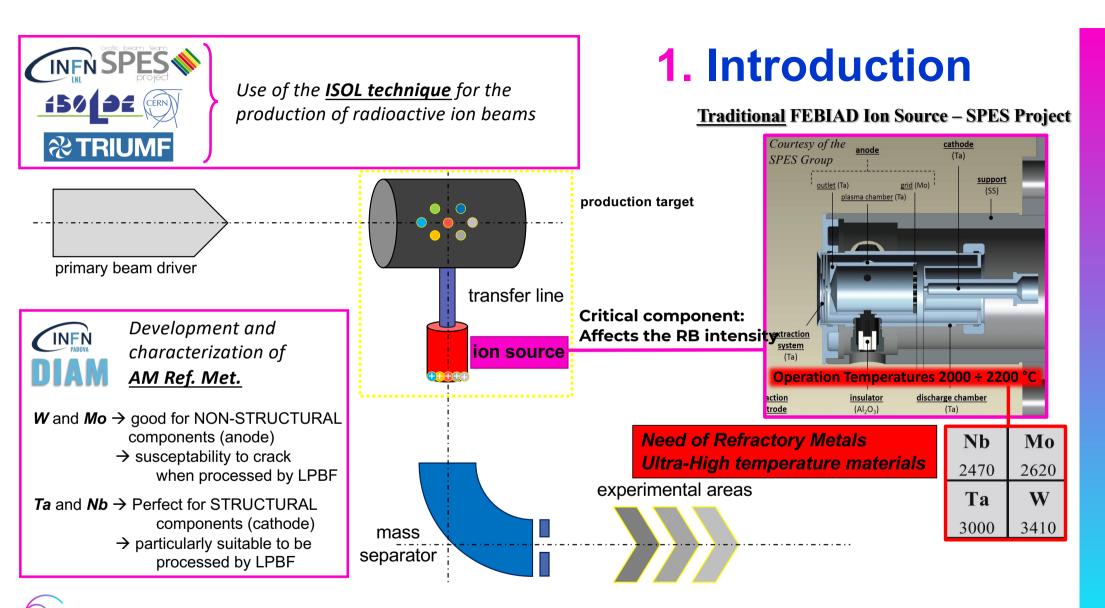
Eng. Adriano Pepato Dirigente Tecnologo INFN



SUMMARY

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- 6. Milestones and Deliverable
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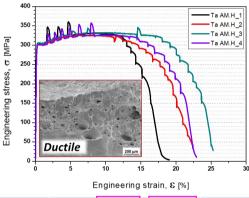
Eng. Adriano Pepato – I.FAST IIF – Nov. 16th, 2022

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1b. AM Material Properties



High Density (> 99.8%)
Mechanical properties higher than STD tantalum



| Sample | E [GPa] | σ _y [MPa] | UTS [MPa] | A [%] |
|--------|---------|----------------------|-----------|-------|
| Ta STD | 173 | 155 | 210 | > 50% |
| Ta AM | 177 | 300 | 330 | ~22% |

• Suitable for <u>STRUCTURAL</u> components (ex. Cathode)

AM Cathode - Ta



Nb TANIOBIS

• High Density (> 99.8%)

• Extreme geometrical integrity during the production process



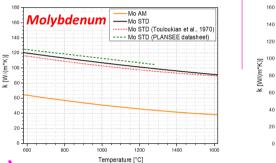


AM SRF 6GHz cavity - Nb



• High Density (> 99.9%)

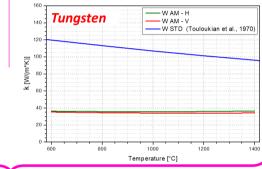
• Thermal and mechanical properties lower than STD



W

• High Density (> 99.6%)

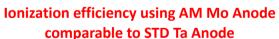
• Thermal and mechanical properties lower than STD

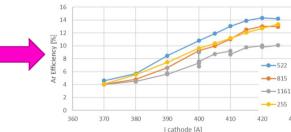


Suitable for <u>NON-STRUCTURAL</u> components (i.e. Anode)

AM Anode - Mo





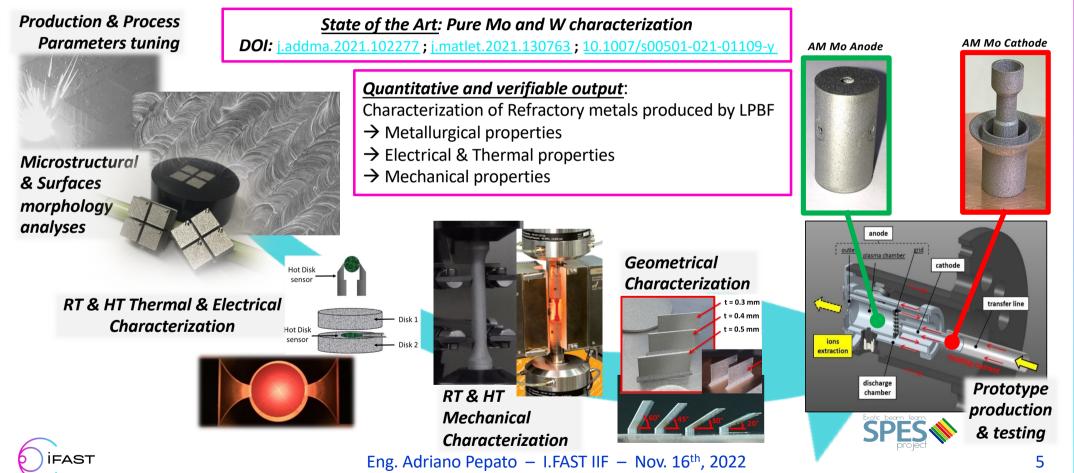


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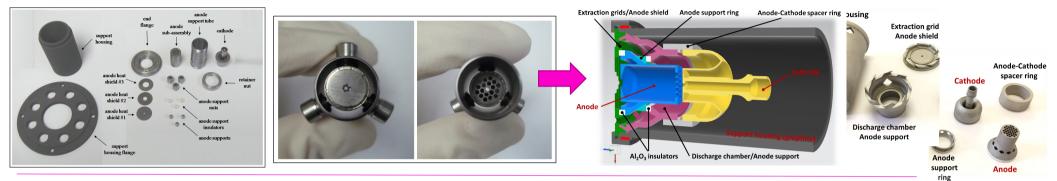
2. Project Objectives

Development of new Refractory Metals Alloys specifically Design for Additive Manufacturing DfAM (LPBF process)
 → Define the best element choice in order to improve the physical performance of the ion sources (Ta-based and/or Nb-based alloys) or to solve the fabrication defects related to pure metals production (W-based and/or Mo-based alloys).



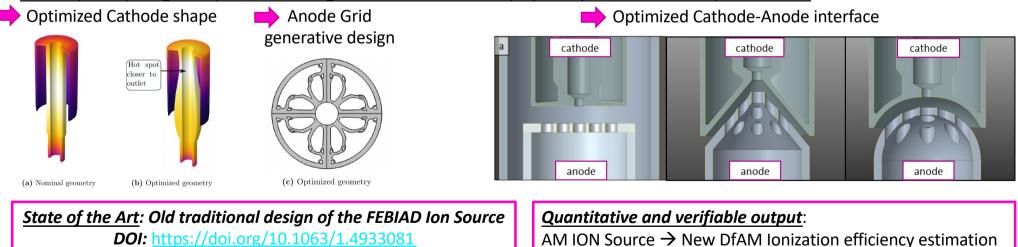
2. Project Objectives

2. Development and Off-line/On-line test of a New ION source designed for Additive Manufacturing production in order to: \rightarrow Improve the Assembly phase: components n° reduction (from n° components > 20 \rightarrow to max 8 components)



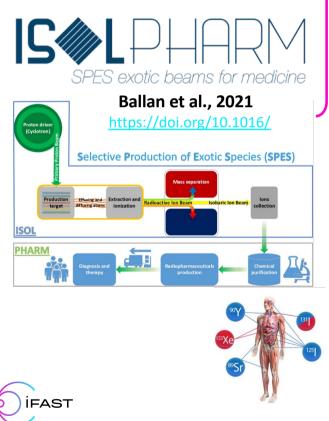
→ Develop a topological optimized design for the ION source physical performance improvement

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POTENTIAL APPLICATIONS of AM - ISOL Ion Sources





investigate the feasibility of using ISOL technology to produce radionuclides as radiopharmaceutical precursors. expected impact of the project in term of: addressable and obtainable market

Commercialization and Market Analysis:

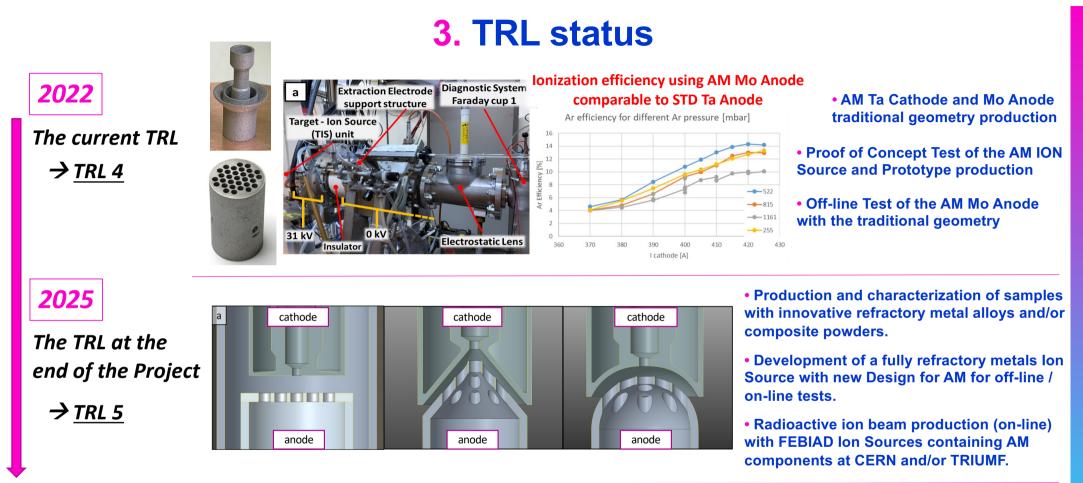
The goal is to confirm the AM technology and the FEBIAD-like ion sources for the

- MEDICAL RADIO THERAPY
- RADIOACTIVE ION BEAMS



how the project addresses the environmental challenges

- AM technology reduced the amount of wasted material
 - The un-melted powder can be entirely recycled
- Post-processing, which involved material waste and high energy consumption, are almost completely avoided.
- ISOL technologies for production of medical radionuclides can become a green alternative to nuclear fission reactors.



Future

Estimated time for <u>TRL 6</u>

"Technology demonstrated in relevant environment (industrially relevant environment in the case of key enabling technologies)"

2026-2027



4. Project Organization

Organizational Expertise



WP1. Development and Characterization of Innovative Refractory Metals and their Alloys by AM Technology

WP2. Development of Additively Manufactured Ion Source Components

WP3. High Temperature Tests and Beam Production with Additively Manufactured Ion Source Components



5. Work Package and Timetable

| WP1. Development and Characterization of Innovative Refractory Metals | | y | ear 1 | | | year 2 | | | End of IIF |
|--|---------------|----|-------|-----|-----|------------|-------|-----|------------|
| and their Alloys by AM Technology | M3 | M6 | M9 | M12 | M15 | M18 | M21 | M22 | M26 |
| T1.1. Production and characterization of Additively Manufactured Ta and/or Ta-based alloys. | | | | | | | | | |
| T1.2. Production and characterization of Additively Manufactured Nb and/or Nb-based alloys. | | | | | | | | | |
| T1.3. Identification and Development of refractory metal alloys and/or composite powders specifically designed for LPBF process. | | | | | | | | | MS.1 |
| T1.4. Production and characterization of samples with innovative refractory metal alloys and/or composite powders. | | | | | | | | | |
| WP2. Development of Additively Manufactured Ion Source Components | | y | ear 1 | | | ye | ear 2 | | End of IIF |
| | M3 | M6 | M9 | M12 | M15 | M18 | M21 | M22 | M26 |
| T2.1. Multiphysics Simulation of Ion Sources with dedicated numerical models. | | | | | | | | | |
| T2.2. Redesign of specific Ion Source components for an improved assembly repeatability considering hybrid AM-traditional techniques. | | | | | | | | | MS.2 |
| T2.3. Development of innovative Additively Manufactured free-form geometries to improve the performance of specific Ion Source components. | | | | | | | | | |
| T2.4. Development of a fully AM Ion Source prototype for off-line / on-line tests. | | | | | | | | | |
| WP3. High Temperature Tests and Beam Production with Additively | year 1 year 2 | | | | | End of IIF | | | |
| Manufactured Ion Source Components | M3 | M6 | M9 | M12 | M15 | M18 | M21 | M22 | M26 |
| T3.1. High temperature tests of AM Ion Source components. | | | | | | | | | |
| T3.2. Thermionic emission tests of AM FEBIAD cathodes and anodes. | | | | | | | | | |
| T3.3. Stable ion beam production (off-line) with FEBIAD Ion Sources containing AM components at CERN and/or INFN-LNL. | | | | | | | | | MS.3 |
| T3.4. Radioactive ion beam production (on-line) with FEBIAD Ion Sources containing AM components at CERN and/or TRIUMF. | | | | | | | | | |

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6. Milestone and Deliverable

| WP1 miles | stones | Date | | | |
|-----------|--|------|--|--|--|
| | Production and characterization of Additively Manufactured Ta and/or Ta-based alloys. | | | | |
| MS.1 | Production and characterization of Additively Manufactured Nb and/or Nb-based alloys. | M26 | | | |
| 1013.1 | Identification and development of refractory metal alloys and/or composite powders specifically designed for LPBF process. | | | | |
| | Production and characterization of samples with innovative refractory metal alloys and/or composite powders. | | | | |
| WP2 miles | stones | Date | | | |
| | Development of Multiphysics numerical models for the simulation of FEBIAD Ion Sources. | | | | |
| | Redesign of specific FEBIAD Ion Source components for an improved assembly repeatability. | | | | |
| MS.2 | Multiphysics Simulation of FEBIAD Ion Sources with innovative free-form geometries. | M26 | | | |
| | Production of free-form cathodes and anodes for ISOL FEBIAD Ion Sources. | 7 | | | |

Production of a fully AM FEBIAD Ion Source prototype.

| WP3 miles | stones | Date |
|-----------|---|------|
| | High temperature tests of AM Ion Source components. | |
| | Thermionic emission tests of AM FEBIAD cathodes and anodes. | 1 |
| MS.3 | First off-line ionization tests with a hybrid AM-traditional ion source prototype. | |
| | First off-line ionization tests with a fully AM ion source prototype. | 1 |
| | On-line beam production at CERN-ISOLDE and/or TRIUMF with a FEBIAD Ion Source containing AM components. | 1 |

WP1, D1 (M24): Written report on the production and characterization of samples with innovative refractory metal alloys and/or composite powders.

WP2, D1 (M24): Production of a fully AM FEBIAD Ion Source prototype with related CAD documentation.

WP3, D1 (M24): Written report on test with FEBIAD Ion Sources containing AM components.



INFN-PD In-Kind Contributions

| Item | FTE months | personnel costs (EUR) | capital costs (EUR) | type of capital cost | Sum (EUR) |
|--|---------------|--------------------------|------------------------|----------------------------|--------------|
| AM Sample production for material characterization | 3 | 3 800 | 0 10000 | Infrastructure consumables | 18000 |
| AM ion source components design | 2 | 2 500 | 0 C | None required | 5000 |
| AM ion source production | 3 | 3 800 | 10000 | Infrastructure consumables | 18000 |
| Post-processing mechanical workshop | 3 | 3 600 | 4000 | Infrastructure consumables | 10000 |
| Total | 11 | L 1700 | 0008 0 | l. | 51000 |

INFN-LNL In-Kind Contributions

| Item | FTE months | personnel costs (EUR) | capital type of costs (EUR) capital cost | Sum (EUR) |
|-------------------------------------|---------------|--------------------------|---|--------------|
| Numerical Simulations | 1.5 | 5 3000 |) 0 None requir | ed 3000 |
| Thermal-electrical characterization | 1 | 4000 | 2000 Infrastructur consumable | 6000 |
| Mechanical characterization | 1 | 4000 | 2000 Infrastructur consumable | 6000 |
| Offline Studies | 2 | 2 6000 |) 4000 Infrastructur consumable | 10000 |
| Total | 5.5 | 5 17000 | 8000 | 25000 |

CERN In-Kind Contributions

| ltem | FTE months | personnel costs (EUR) | capital type of costs (EUR) capital cost | Sum (EUR) |
|--------------------------|---------------|--------------------------|--|--------------|
| Numerical Simulations | | 1 1000 | 0 None required | 10000 |
| Offline Studies | | 2 2000 | two offline target assemblies 10000 and infrastructure consumables, computer tomography, material test | 30000 ing |
| Online Studies | | 1 1000 | 10000 Online target assembly and tests | 20000 |
| Total | | 4 4000 | 20000 | 60000 |

TRIUMF In-Kind Contributions

| Item | FTE months | personnel costs (EUR) | capital costs (EUR) | type of capital cost | Sum (EUR) |
|---------------------------------|---------------|--------------------------|------------------------|---|--------------|
| Numerical Simulations | : | 2 14.800 |) | 0 None required | 14.800 |
| Offline Studies | : | 3 22.200 |) 17.7 | 60 infrastructure consumables | 39.960 |
| Online Studies | 3 | 3 22.200 | 21.8 | 30 Online target assembly, NRE | 44.030 |
| Online Material Irradiations | : | 2 14.800 | 7.0 | 30 Irradiation sample holders, sample preparation consumables | 21.830 |
| Total | 10 | 0 74.000 | 46.6 | 20 | 120.620 |

TANIOBIS In-Kind Contributions → 25000 EUR

SAES-GETTERS In-Kind Contributions → 20000 EUR

GE-UPPSALA In-Kind Contributions → 14700 EUR

♦ TOTAL IN-KIND: 326 k€

7. Budget

→ 14700 EUR

EOS In-Kind Contributions → 10000 EUR

✓ THE FUNDING REQUIRED: 100 k€

INFN-PD → 50 k€

- Personnel: 25 k€
- □ Consumables: 15 k€
- □ Travels: 10 k€

INFN-LNL → 25k€

- Personnel: 15 k€
- □ Consumables: 4 k€
- □ Travels: 6 k€

ISOLDE-FACILITY-CERN → 25k€

- □ Consumables: 20 k€
- □ Travels: 5 k€

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Thank you for your attention!

Contact information

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To Eng, Adriano Pepato Legnaro, 28th June 2022 Head of DIAM workgroup – INFN Padua Division To Eng, Mattis Manzolaro (SOL targets and in sources – Research Division – INFN-LNL

Dear Adriano and Mattia

I have read the validity of the initiative made by your research groups for the LFAST innovation fund proposal (https://fistproject.eu/ifast-innovation.fund) in the context of the LFAST project (https://fastproject.eu/pome).

Considering that the development of FEBIAD-like ion sources via Additive Manufacturing (AM) technology will have a strong influence on the ionization performance and consequently also on the finure outlook of radioactive ion beams production for medical applications, we strongly encourage the research project activities proposed by your research groups and we are interested in participating to it.

> Sincerely, On behalf of INFN LNL – ISOLPHARM project





35020 Legnaro (PD) – Viale dell'Università, 2 – Tel. 040/80.68318 – Telefax 040/641925 Alberto Andrighettogjini.infn.it Codros Fiscale 84001850690

Eng. Adriano Pepato Head of DIAM workgroup – INFN Padua Division To Eng. Mattia Manzolaro ISOL targets and ion sources – Research Division – INFNLNL

RE: Expression of interest to participate in the LFAST Innovation Fund project on additively manufactured ion sources for producing ion beams

Tomas Eriksson

GEMS PET Systems AB

S-750 15 Uppsala

GE Healthcare Chief Cyclotron Enginee Phone: +46 72 5103226

Box 15024

Sweden

Dear Ing. Pepato, Dear Ing. Manzolaro

For General Electric (GE) the accelerator business is a most important part of our Healthcare division. In this case it is especially interesting in the scope of GE's Cyclotrons used for producing PET (Positron Emission Tomography) radioisotopes used for PET scanner diagnosing of e.g. cancer tumors.

GE Healthcare in Uppsala, Sweden, produces two types of cyclotrons for this purpose, PETtrace with 16.5 MeV proton and 8.4 MeV deuteron capability and MINItrace with 9.6 MeV protons.

For the medical PET radioisotope producing cyclotrons, it is most important to have a wellfunctioning, reliable as maintenance free as possible ion source. This is needed to reliably deliver the PET radioisotopes to the waiting patients. Reduced maintenance is also very important in order to reduce the radiation dose to maintenance personnel.

GE does from earlier experience believe that additive manufacturing techniques can provide great advantages in terms of freedom to mechanically design parts and to introduce new materials. For this reason GE has a great interest to participate in the LFAST project (https://fiastproject.eu/home) as we see it as a stimulating and challenging opportunity to explore the manufacturability of Rey components and systems using alternative and innovative approaches.

Sincerely and to Comas Eriksson **GE Healthcare**

GE Healthcare Chief Cyclotron Engineer

∂TRIUMF



To: Mattia Manzolaro and Adriano Pepato, Istituto Nazionale di Fisica Nucleare

RE: Expression of interest to participate in the LFAST Innovation Fund project on additively manufactured ion sources for radioactive ion beams

This letter is to express TRIUMF's interest in the participation in the LFAST Innovation Fund project initiative on additively manufactured (AM) radioactive ion beam ion source components, led by Adiano Pepato and Martin Manzolaro, DNPN, Leganco.

TRIUMF is Canada's National Accelerator Centre, specialized in building paticle scolerator infrastructure that enables couring-dega multicologically research. ITRUMF's flagshipp program in the delivery of radioistops beams (REF) to a wide range of search and applications. We are currently investing into an expansion of one REF complex. Preporting to a substantial oversubsciption of expensional beam time, the ARTEL facility will allow to deliver there REBs isumbianeously to existing state of the art experimental end stations. However, even a fast checkes of search and development, the dominaring lamition of all interastional radioscope beam programs in the low radiorrable estimates or beam instanty. For thick target facility, this is caused by low efficiences of extraction and ionization of these encoire radioscopes. The proposed project has the potential to servicinomize the manufacturing process of REB ion sources and to prove the way towards injudication improvement of REB intensity with will be robe scentific programs. Resent rudies have shown, that more efficient and more reliable ion sources parameters because and bable.

TRUMF is conducting continuous research and development on new target and ion source designs, including the use of AM technology. Resently, the TRUMH wates-cooled hemetic target vessel has been replaced by an AM almainma body, which enables gestere performances at reduced manufacturing pice. Almo, composite target converses materials have been prototyped and tunkie undate inradiation. These copper-tangetse, almainma-tantham, copper-bergliam layer composites are promising candidates that combine the design fierbilly of AM with proven nuclear metasials to analy engeneedened performance.

GE Healthcare - MICT Cyclotron irradiation, numerical simulation and financial resources available to support the proposed activities.

Bet regards, Saes Dr. Alexander Cottberg Department Head, Targets and Ion Sources SAES Getters S.p.A.

t +1 (604) 222 7689 www.triumf.ca 4004 Wesbrook Mail gottberg@triumf.ca @TRIUMFLab Vancouver BC V&T 2A3 Canada

To Eng. Adviano Repato Head of DIAM workgroup – INFN Padua Division To Eng. Mattia Manatoiro Joci, turgies and ion sources: Research Division – INFN-Soci, turgies and ion sources.

> RE : Expression of interest to participate in the I.FAST Innovation Fund project on additively manufactured ion sources for radioactive ion beams

Dear Ing. Pepato, Dear Ing. Manzolaro

The scientific and technological accelerator community is one of the key area where SAES getters have been traditionally involved ince decades. SAES provides high and with high vacuum pumps based on getter technology and integrated solutions for accelerators including Non Evaporable Getter coarded vacuum chambers, complex composents and scientific instrumentation for beam lines and accelerators. Through the research acquisition of SAES FIALV accoum and Sormenet Scientific Card SAES has further interasted in focus on providing vacuum solutions based on advanced materials, uncovarive manufacturing techniques and avoid edigin.

manufacturing techniques and novel design. We are therefore very interestication your miniative (https://ifast-project.ewifast-innovation-fund) in the context of the LFAST project (http://ifast.groeget.ewhome) as we need it as a stimulating and challenging opportunity to explore the manufacturability of components and systems using alternative and innovative approaches.

Due to this, SAES is very interested in participating to the activity proposed by your Group. As a manufacturing company with a strong from on innovation, we can deploy FAED and engineering resources as well as competence in material actione and any curatum technology. ASES can also leverage on its international commercial network to gather marketing and application information to more effectively capture the accelerator community needs.

Sincerely

Sals Main



EOS GmbH Electro Optical Systems • Robert - Stirling - Ring 1 • D-82152 Krailling

I.N.F.N. - Sezione di Padova Servizio Progettazione Meccanica Ing. Pepato Adriano Via Marzolo 8 - 35131 - Padova Italy

> Paula Kainu +358 40 75 14516 paula.kainu@eos.info November 1, 2022

eme

Expression of interest to participate in the I.FAST Innovation Fund project on additively manufactured ion sources for radioactive ion beams

Dear Ing. Pepato, Dear Ing. Manzolaro,

This letter is to express EDS' interest in the participation in the LFAST Innovation Fund project initiative on additively manufactured (AM) radioactive ion beam ion source components, led by Adriano Pepato and Mattik Manzolaro, NIRN, Legnaro.

EOS is leading supplier for responsible manufacturing solutions via industrial 3D printing technology, EOS GmbH was founded in 1989 and the company is a pioneer and innovator for compretensive customer solutions in Additive Manufacturing, EOS solutions product portfolio of systems, materials and process parameters gives customers cuical competitive advantages in terms of product quality and the long-term economic sustinability of ther manufacturing processes. EOS has over 30 years of experience in developing materials and processes for Additive Manufacturing and has forwalter ters of industrial. AM solutions to the market. These solutions range across industries, from aerospace to automotive and from medical to turbomachinery.

One of the most successful AM solutions has been the development of tungsten for antiscatter grids to improve CT image quality. During this development, EOS has generated extensive knowledge about processing of refractory materials (lungsten as well as molydderum) in isser power bed fusion. As fully dense microstructure is very hard to active, it is critical to define the exact requirement teves and tailor the development according to them. This way the utilization of AM refractory materials in further applications can be achieved and EOS is committed in supporting this development.

EOS is very excited about this project as it sees potential in this application area, to greatly enhance the performance of ion sources. EOS will support the project by consulting the development plans when & where needed, by updating the project on the relevant developments ongoing on EOS side, and by building refractory material parts where possible.

July 11th 2022

With best regards EOS GmbH Electro Optical Systems

Paula Kainu Business Development Manage

| EOS GmbH Electro Optical Systems Robert-Scinling-Ring 1 | HypoVereinsbank | SWIFT: HYVEDEMN000X I&AN: DE81 7002 0270 0044 6197 80 € | Management | Dr. Florian Mea Marie Niehaus-Langer |
|--|-----------------|--|-----------------|--|
| D-52152 Krailling/Munich, Germany | DZ Bank AG | SWIFT: GENODEFF 701 | | Nikolai Zaepernick |
| Phone +49 89 893 26-0 Telefax +49 89 893 36-285 | | IRAN: DE32 7016 0000 0000 1396 08 € IRAN: DE02 7016 0000 0020 1396 08 € | Company reg. In | Munich HR8 87386 Tax No. DE 12 933 9753 |

Eng. Adr



Extra. Personnel

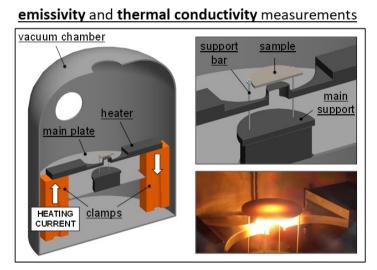
| | I <u>NFN - PD</u> | | | | | | | |
|-----------------|---|-------|------------|--|--|--|--|--|
| Name | Expertise – Activity in the project | WP | FTE months | | | | | |
| Adriano Pepato | Project coordinator, DIAM technical coordinator | 1,2,3 | 1 | | | | | |
| Matteo Turcato | | 1,2,3 | 2 | | | | | |
| Marco Romanato | | 1,2,3 | 2 | | | | | |
| Daniele Mazzaro | | 1,2,3 | 3 | | | | | |

| I <u>NFN - LNL</u> | | | | | | |
|--------------------|---|-------|------------|--|--|--|
| Name | Expertise – Activity in the project | WP | FTE months | | | |
| Mattia Manzolaro | FEBIAD-like Ion Source development, SPES ISOL machine management, | 1,2,3 | 0.5 | | | |
| Michele Ballan | FEBIAD-like Ion Source development, thermal and electrical characterization, offline ion source studies | 1,2,3 | 2 | | | |
| Lisa Centofante | FEBIAD-like Ion Source development, mechanical characterization, offline ion source studies | 1,2,3 | 2 | | | |
| Alberto Monetti | FEBIAD-like Ion Source development, mechanical characterization, offline ion source studies | 1,2,3 | 1 | | | |

| T <u>RIUMF</u> | | | | | | | |
|---------------------|---|-----|------------|--|--|--|--|
| Name | Expertise – Activity in the project | WP | FTE months | | | | |
| Alexander Gottberg | Radioactive beam ion beam production, radiation damage in materials, TRIUMF coordinator | 2,3 | 2 | | | | |
| Thomas Day Goodacre | Radioactive beam ion sources, coordinator of offline ion source studies | 2,3 | 3 | | | | |
| Carla Babcock | Online radioactive beam ion beam production, coordinator of online ion source studies | 2,3 | 1 | | | | |
| Ferran Boix Pamies | Material irradiation studies, microstructure, mechanical properties, coordinator of irradiation studies | 2,3 | 3 | | | | |
| Fernando Maldonado | Numerical simulations (thermal, mechanical, electromechanical, electron and ion beam tracking) | 2,3 | 2 | | | | |

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INFN-LNL Contributions



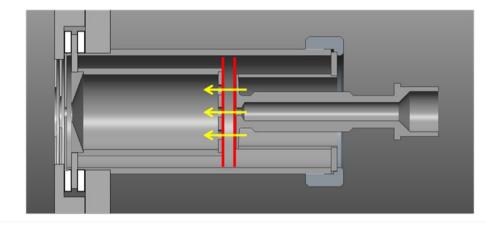
electrical resistivity measurements



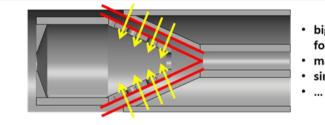
FAST



planar interface and electron beam in the axial direction (STANDARD)



conical/spherical/free-form interface to improve the electron flux (AM)



- bigger surface at high temperature for electron emission
- magnetic field not required
- simplified vacuum chamber design

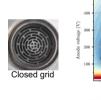
thermionic emission measurements multiphysics simulations

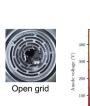
TRIUMF Contributions

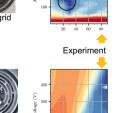
TRIUMF is Canada's Particle Accelerator Centre and is operating FEBIAD-type ion sources to produce radioactive isotope beams for fundamental research, as well as for medical and material applications. Summary of recent FEBIAD studies at TRIUMF: http://hdl.handle.net/1828/14082

Contributions to this project are in-kind and aligned with available expertise and priorities at TRIUMF

- 1. Support development of new ion source geometries through numerical FEA and multi-physics simulations to assess the temperature profile, the electron beam density, the electric field distribution inside of the anode and finally the ionization efficiency and ion beam emittance. This will result in gualifying a set of geometries for experimental studies.
- 2. Full ion sources of selected geometries will be manufactured by through this collaboration and integrated into dedicated TRIUMF radioisotope beam production target assemblies. These assemblies are used for offline studies assessing the performance of the ion source to ionize stable ion beam with high efficiency and reliability to validate the manufacturing processes, as well as the performance improvements predicted from the newly available complex geometries.
- 3. To gualify the AM methodology for this application, material irradiation damage studies will be conducted using an existing 500 MeV irradiation station. Different refractory AM materials will be gualified for high-energy and high-power particle irradiation by assessing their mechanical properties before, during and after irradiation.
- 4. After offline validation, a selected geometry will be integrated into an online TRIUMF radioisotope production target and submitted to 500 MeV proton beam. These online studies will act as TRL5 for the production of radioactive isotope beams using tailor-made AM ion source.



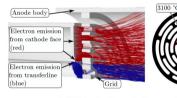


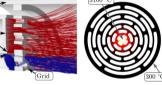


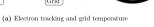
Coil current (A)

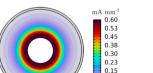
Simulation

Coil current (A)



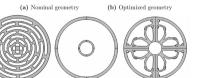






0.08 0 00 (b) Electron current density at the cathode

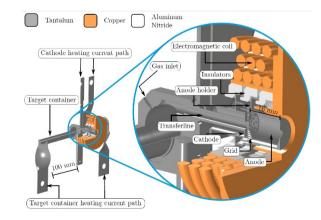




Grid generative-design-optimization

Eng. Adriano Pepato – I.FAST IIF – Nov. 16th, 2022





Cathode shape-optimization

High Vacuum Division

SAES Getters contribution

- SAES getters is an Italian company with a strong focus on accelerator community to which it supplies NEG pumps since the 70s and more recently vacuum chambers, components and scientific instrumentation for synchrotron beamlines through SAES RIAL Vacuum and Cinel (both 100% part of the SAES Group).
 - SAES is relatively new to AM but keen to explore the opportunities of this technology for accelerator components like the ion sources with improved efficiency and design.
 - SAES will dedicate marketing and commercial resources to map the existing facilities, evaluate the applicability and advantages of the FEBIAD design, quantity the potential needs and the technical requirements. This should provide a clear perspective about the potential market, the requirements and also a viable route to the technology diffusion.
 - SAES will also take care of exploring the IP matter through its internal IP office.
 - As a manufacturing company, SAES is also potentially interested in manufacturing and selling the ion sources themselves. We will explore this opportunity in the course of the project.
 - The project leader for SAES is Dr. Michele Mura, Head of the Divisional Development Lab. One senior technician and a sales/marketing expert will support the technical and market scouting activity, respectively.
- A total of 4 months (2 people for 2 months) over the span of the project will be deployed. The estimated cost is 20KEuro which will be fully absorbed by SAES as in kind contribution to the project.





making innovation happen, together

The possible contribution requested to EOS:

- Production of samples for material properties evaluation (ex. Cubes for density measurement, samples for mechanical static test, cylinder of 40mm diameter and 20mm high for thermal properties) using one of the selected refractory metals alloy Mo-based (ex. TZM) as well as optionally Nb and/or Ta
- Production of non-structural components prototype of the ION Source (ex. Anode about 30 mm high and 15 mm diameter) using one of the selected refractory metals alloy Mo or W-based aforementioned.

Requirements:

- Use of a LPBF machine that
 - allows the platform to be heated up to 450°C and/or 800°C
 - o allows the application of a controlled cool down (ex. at a rate of 100 °C per hour).

<u>Reference</u>: the machine that EOS has supplied to PLANSEE (see the link of the paper below).

State of the Art: https://doi.org/10.1016/j.ijrmhm.2020.105369

What is provided to EOS:

- The powders, which will be purchased using the budget provided by the project (pre-processing step)
- The material characterization using the sample produced by EOS (post-processing step) as well as in-application (ion source) performance data
- Contribution/support for process parameters tuning based on INFN DIAM experience with pure refractory metals production and characterization.



In-kind contribution:

EOS will contribute by producing samples as described in this document

In-kind contribution elements:

- Engineering resources
- Machine operation resources
- Machine time (up to 5 jobs per system type)
- Total in-kind contribution: 8 000 10 000 €

•At EOS Finland, we only have a system that can go up to 450C. We have within our ecosystem another system that can go up to 800C, •I need to check about the control on the cooldown, how this is managed

•We would potentially be interested in supporting the project in the Niobium efforts as well – if agreeable to the project, I'll discuss with our R&D

•In this project, besides the characterization data we would like to receive also detailed application performance data (I assume this is already part of the frame work?): FINE

•The in-kind contribution is 8-10k€ because of the uncertainty on the 800C trials and bringing in of Nb, as well as the amount of work finally involved for process settings finding for the higher temperatures



In-kind contribution: TANIOBIS

Markus Weinmann wrote:

we decided to provide you up to 50 kg of Ta or Nb and will support your project with a discount for the powder purchase and personnel efforts in the range of 25.000 €.

